Session #24: Homework Solutions

Problem #1

To increase its corrosion resistance, chromium (Cr) is diffused into steel at 980°C. If during diffusion the surface concentration of chromium remains constant at 100%, how long will it take (in days) to achieve a Cr concentration of 1.8% at a depth of 0.002 cm below the steel surface? ($D_0 = 0.54 \text{ cm}^2/\text{s}$; $E_A = 286 \text{ kJ/mol}$)

Solution

A solution to Fick's second law for the given boundary conditions is:

$$\frac{c}{c_s} = 1 - erf \frac{x}{2\sqrt{Dt}}$$
, from which we get $erf \frac{x}{2\sqrt{Dt}} = 1 - 0.018 = 0.982$

From the error function tables, 0.982 is the erf of 1.67. This means that

$$\frac{0.002}{2\sqrt{Dt}} = \frac{0.001}{\sqrt{Dt}} = 1.67$$

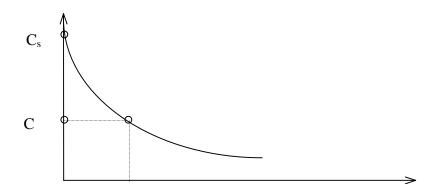
$$D = D_o e^{\left(\frac{-286 \times 10^5}{8.314 \times 1253}\right)} = 6.45 \times 10^{-13} \text{ cm}^2/\text{s}$$

$$t = \frac{0.001^2}{1.67^2 \times 6.45 \times 10^{-13}} = 5.56 \times 10^5 \text{ sec} = 6.4 \text{ days}$$

Problem #2

By planar diffusion of antimony (Sb) into p-type germanium (Ge), a p-n junction is obtained at a depth of 3×10^{-3} cm below the surface. What is the donor concentration in the bulk germanium if diffusion is carried out for three hours at 790°C? The surface concentration of antimony is held constant at a value of 8×10^{18} cm⁻³; $D_{790^{\circ}C} = 4.8\times 10^{-11}$ cm²/s.

Solution



$$\frac{c}{c_s} = \text{erfc} \frac{x}{2\sqrt{Dt}} = \text{erfc} \frac{3 \times 10^{-3}}{2\sqrt{Dt}} = \text{erfc}(2.083)$$

$$\frac{c}{c_s} = 1 - \text{erf}(2.083), \quad \therefore \quad 1 - \frac{c}{c_s} = 0.9964$$

$$\frac{c}{c_{\text{S}}} = 3.6 \times 10^{-3}, ~ \therefore ~ c = 2.88 \times 10^{16} ~ \text{cm}^{-3}$$

The donor concentration in germanium is $2.88 \times 10^{16} / \text{cm}^3$.

Problem #3

You wish to dope a single crystal of silicon (Si) with boron (B). The specification reads 5×10^{16} boron atoms/cm³ at a depth of 25 µm from the surface of the silicon. What must be the effective concentration of boron in units of atoms/cm³ if you are to meet this specification within a time of 90 minutes? Assume that initially the concentration of boron in the silicon crystal is zero. The diffusion coefficient of boron in silicon has a value of 7.23×10^{-9} cm²/s at the processing temperature.

Solution

$$c(x, t) = A + B \text{ erf } \frac{x}{2\sqrt{Dt}}; \ c(0, t) = c_s = A; \ c(x, 0) = c_i = 0$$

$$c(\infty, t) = c_i = 0 = A + B \rightarrow A = -B$$

$$\therefore c(x, t) = c_s - c_s \text{erf } \frac{x}{2\sqrt{Dt}} = c_s \text{erfc} \frac{x}{2\sqrt{Dt}} \rightarrow 5 \times 10^{16} = c_s \text{erfc} \frac{25 \times 10^{-4}}{2\sqrt{7.23 \times 10^{-9} \times 90 \times 60}}$$

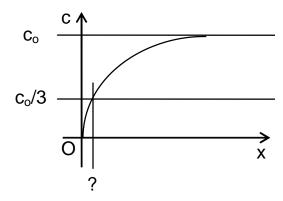
$$\therefore c_s = \frac{5 \times 10^{16}}{\text{erfc}} \frac{25 \times 10^{-4}}{2\sqrt{7.23 \times 10^{-9} \times 5400}} = 6.43 \times 10^{16} \text{ cm}^{-3}$$

Problem #4

A slab of plate glass containing dissolved helium (He) is placed in a vacuum furnace at a temperature of 400°C to remove the helium from the glass. Before vacuum treatment, the concentration of helium is constant throughout the glass. After 10 minutes in vacuum at 400°C, at what depth from the surface of the glass has the concentration of helium decreased to 1/3 of its initial value? The diffusion coefficient of helium in the plate glass at the processing temperature has a value of $3.091 \times 10^{-6} \ \text{cm}^2/\text{s}$.

erfc(0.20) = 1 - erf(0.20) = 1 - 0.2227 = 0.7773

Solution



$$c = A + B \text{ erf} \frac{x}{2\sqrt{Dt}}$$
; $c(0, t) = 0 = A$; $c(\infty, t) = c_0 = B$

$$\therefore c(x, t) = c_0 erf \frac{x}{2\sqrt{Dt}}$$

What is x when $c = c_o/3$?

$$\frac{c_0}{3} = c_0 \text{erf} \frac{x}{2\sqrt{Dt}} \rightarrow 0.33 = \text{erf} \frac{x}{2\sqrt{Dt}}; \text{ erf}(0.30) = 0.3286 \approx 0.33$$

$$\therefore \frac{x}{2\sqrt{Dt}} = 0.30 \ \to \ x = 2 \times 0.30 \times \sqrt{3.091 \times 10^{-6} \times 10 \times 60} = 2.58 \times 10^{-2} \ cm = 258 \mu m$$

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